IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Kazuyuki TOKOROZUKI et al.

Appln. No.:

Filed: Herewith

For: FABRICATION METHOD OF SEMICONDUCTOR INTEGRATED CIRCUIT

DEVICE

PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the aboveidentified patent application as indicated below.

IN THE CLAIMS:

Please cancel Claims 4 and 5 without prejudice.

REMARKS

Claims 4 and 5 have been canceled to avoid the excess claims fee.

The Commissioner is hereby authorized to charge to

Deposit Account No. 50-1165 any fees under 37 C.F.R. §§

1.16 and 1.17 that may be required by this paper and to

credit any overpayment to that Account. If any extension

of time is required in connection with the filling of this

paper and has not been requested separately, such extension

is hereby requested.

Respectfully submitted,

Reg. No. 31,568

MWS:lat

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July 9, 2003